

**Notice of References Cited**

Application/Control No.

09/856,212

Applicant(s)/Patent Under  
Reexamination  
NAKAMURA ET AL.

Examiner

Matthew J Song

Art Unit

1765

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,036,776	03-2000	Kotooka et al.	117/217
	B	US-5,931,662	08-1999	Adachi et al.	118/500
	C	US-5,827,367	10-1998	Wijaranakula et al.	117/200
	D	US-5,900,059	05-1999	Shimanuki et al.	117/217
	E	US-5,954,873	09-1999	Hourai et al.	117/13
	F	US-5,968,264	10-1999	Iida et al.	117/217
	G	US-5,922,127	07-1999	Luter et al.	117/200
	H	US-5,942,032	08-1999	Kim et al.	117/13
	I	US-5,997,640	12-1999	Berthold et al.	117/200
	J	US-5,308,446	05-1994	Bihuniak et al.	117/13
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Zulehner et al., Czochralski- Grown Silicon, 1982, Springer-Verlag Berlin Heidelberg, pgs 19 and 57-91
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a) )  
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